

Docket No. 206645US0

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Takao NOGUCHI, et al.

FILING DATE: Herewith

FOR: MULTILAYER THIN FILM, ITS PREPARATION METHOD AND ELECTRONIC DEVICE

**LIST OF INVENTORS' NAMES AND ADDRESSES**

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

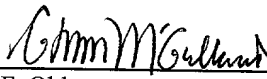
Listed below are the names and addresses of the inventors for the above-identified patent application.

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A declaration containing all the necessary information will be submitted at a later date.

Respectfully Submitted,

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